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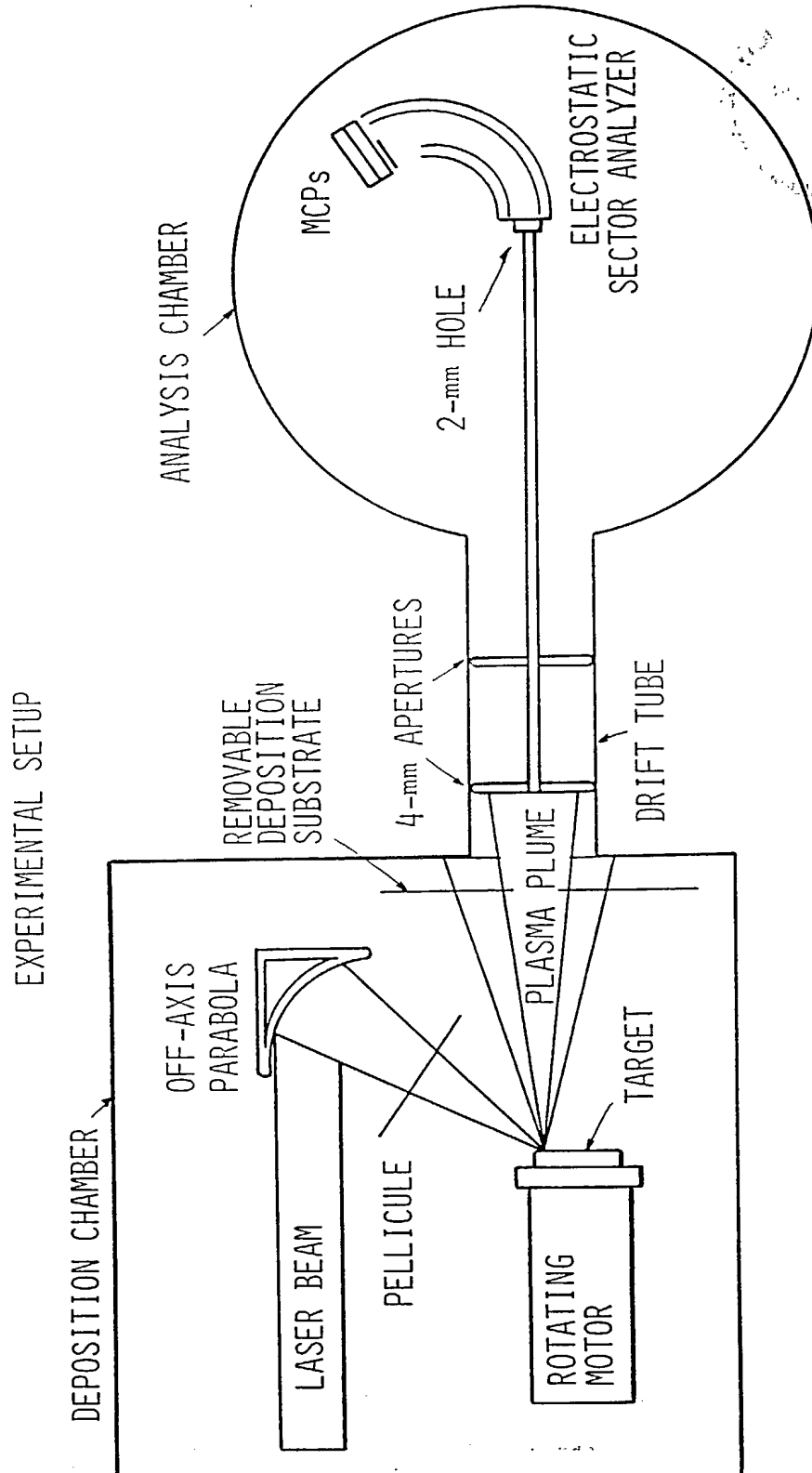
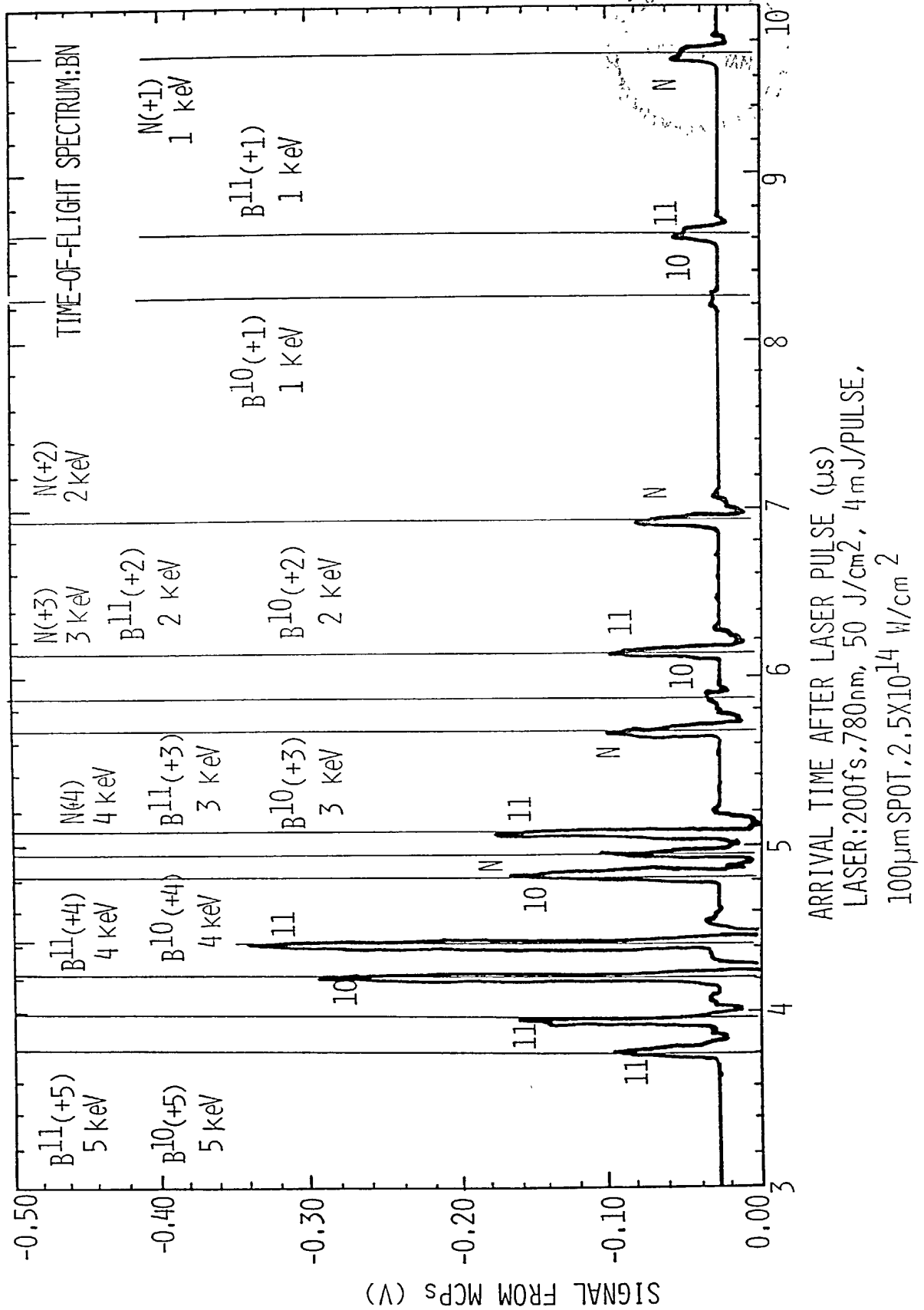


FIG.1

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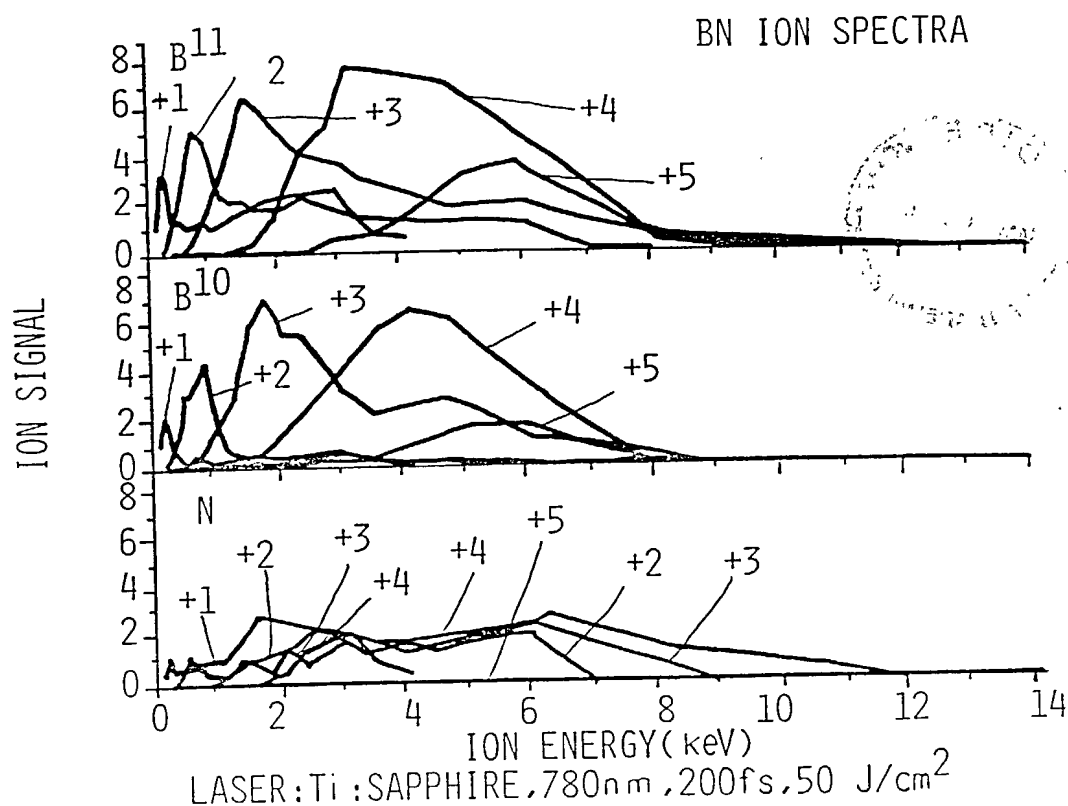


FIG.3A

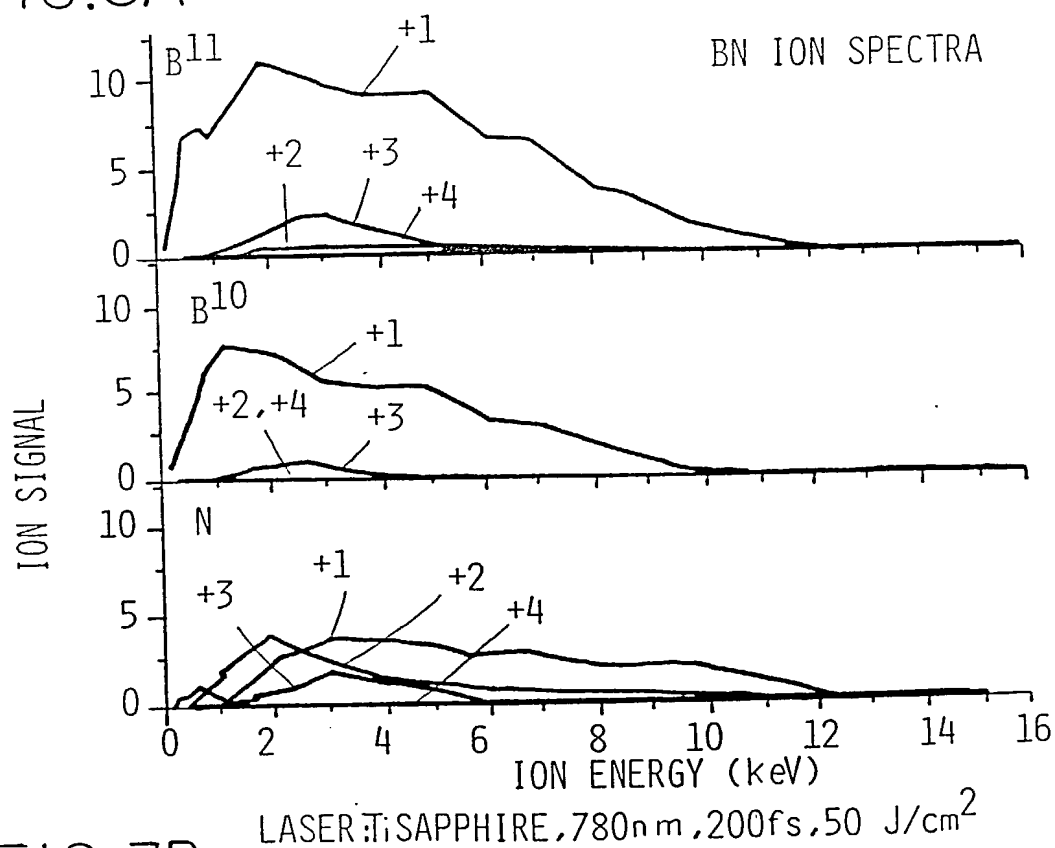


FIG.3B

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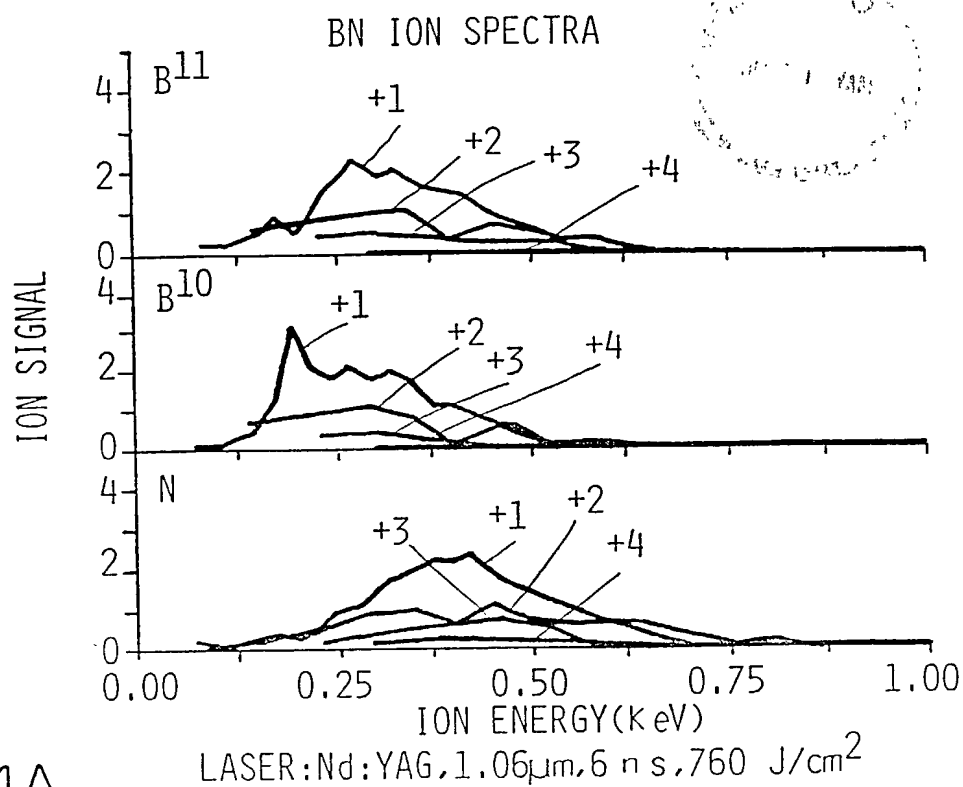


FIG.4A

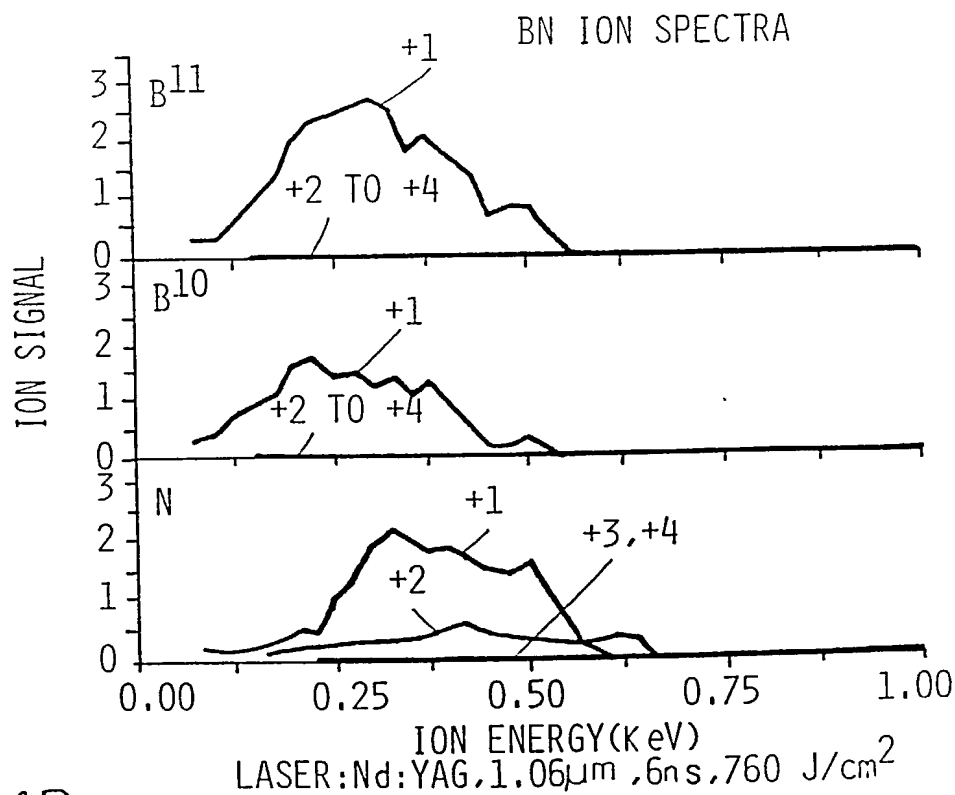


FIG.4B

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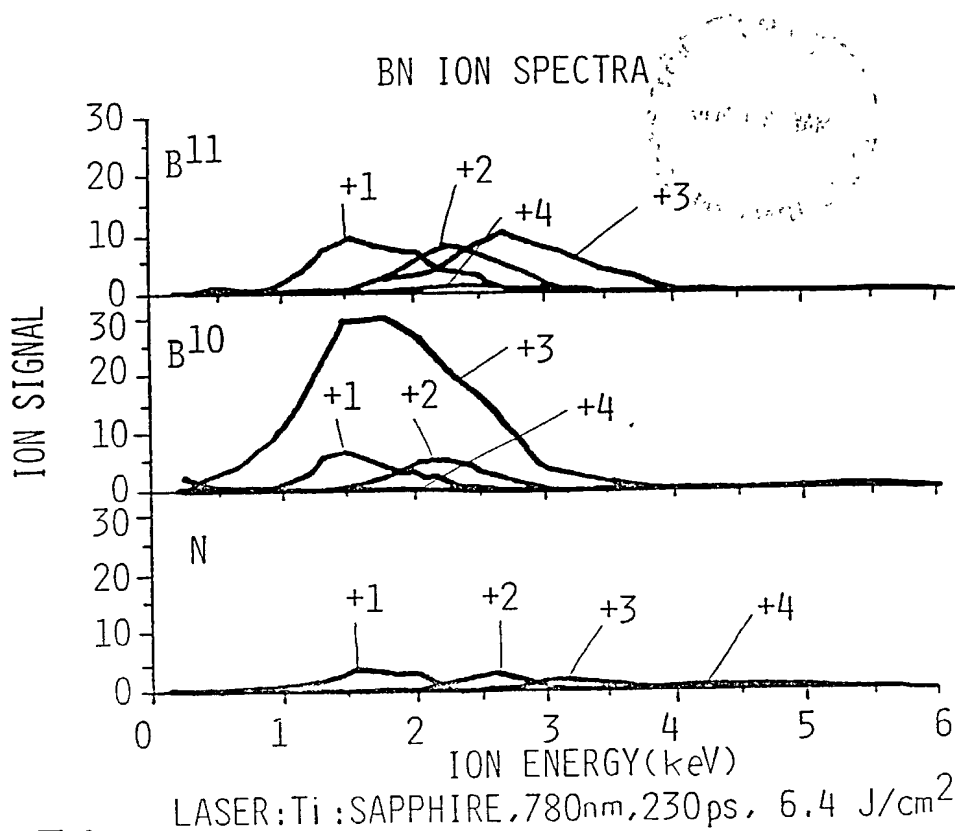


FIG. 5A

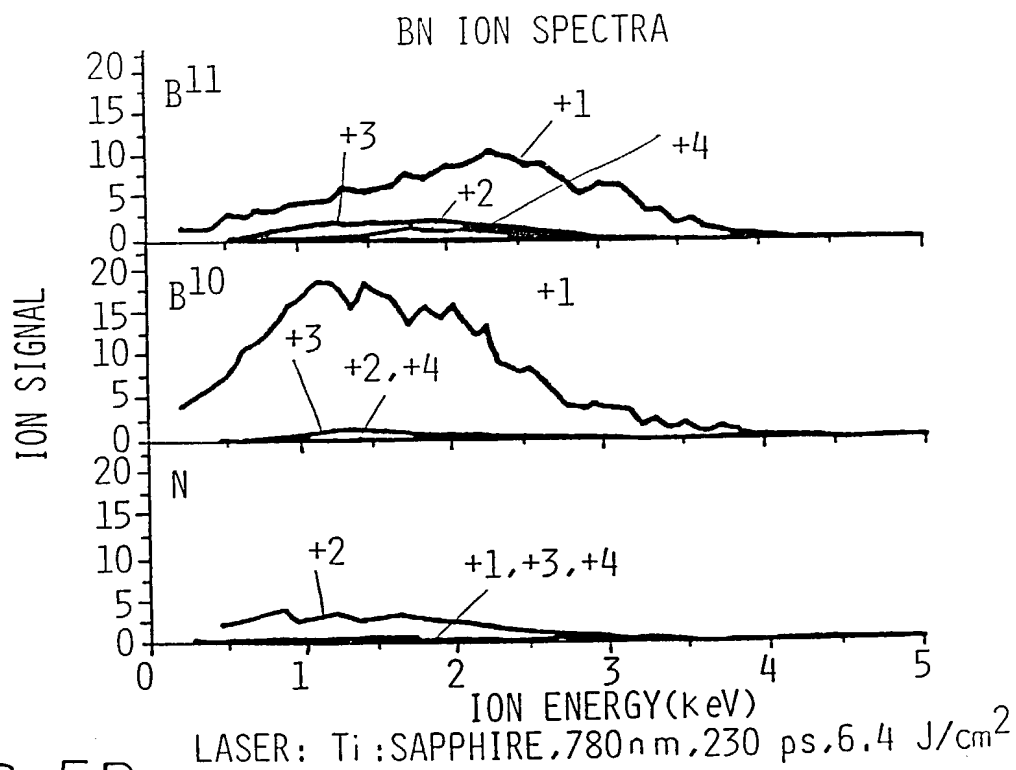


FIG. 5B

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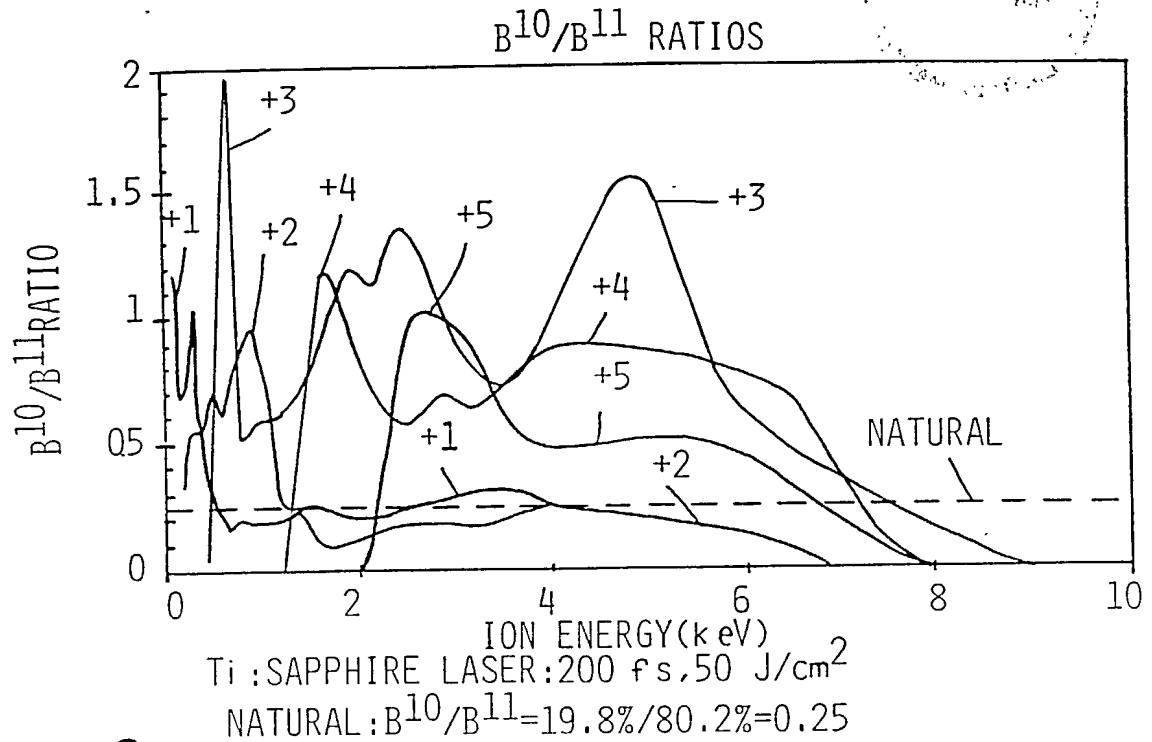


FIG.6A

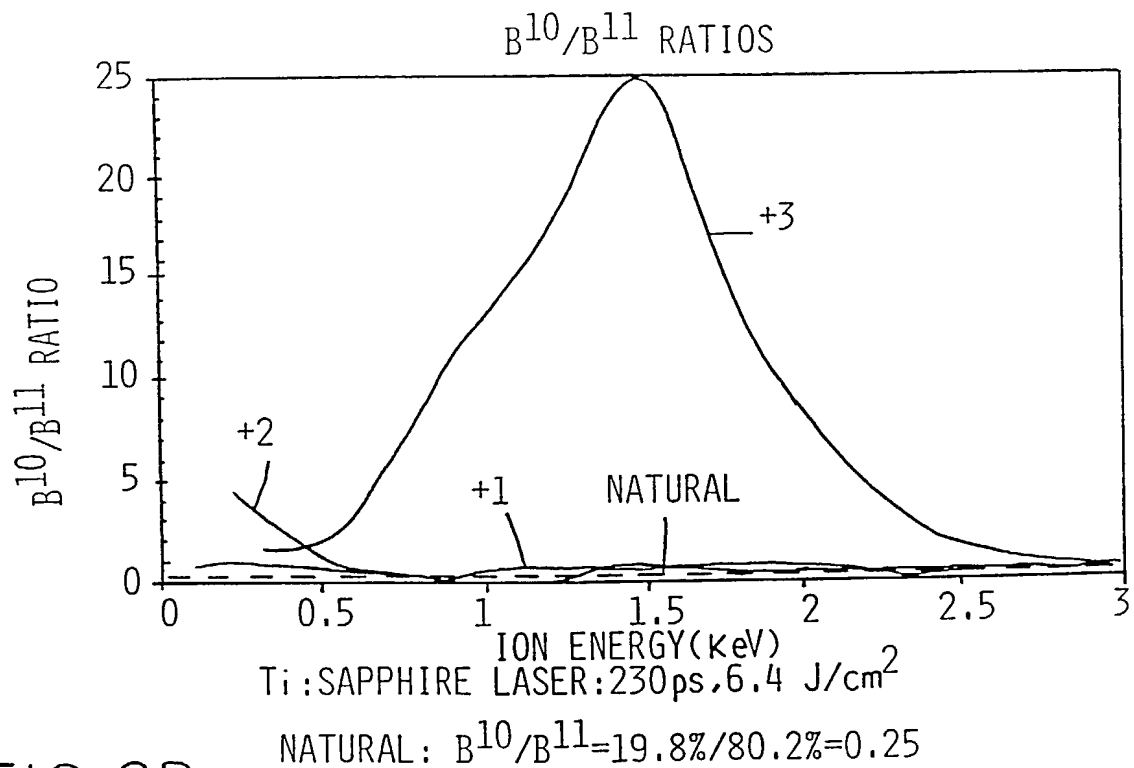


FIG.6B

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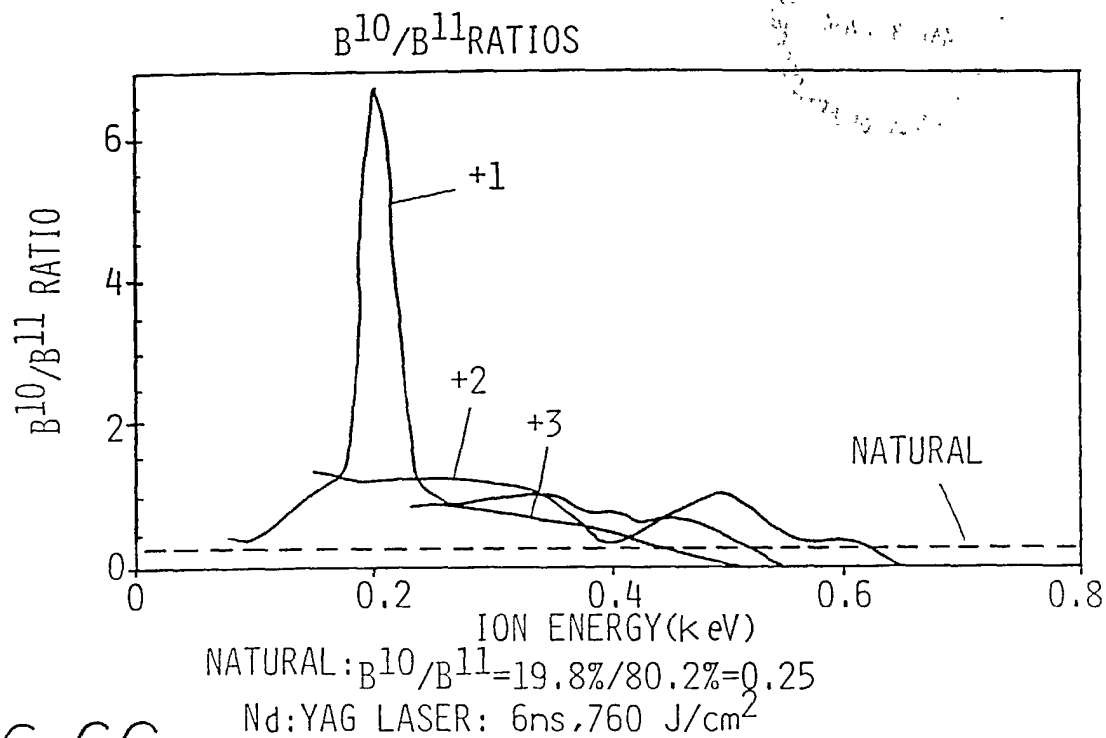


FIG. 6C

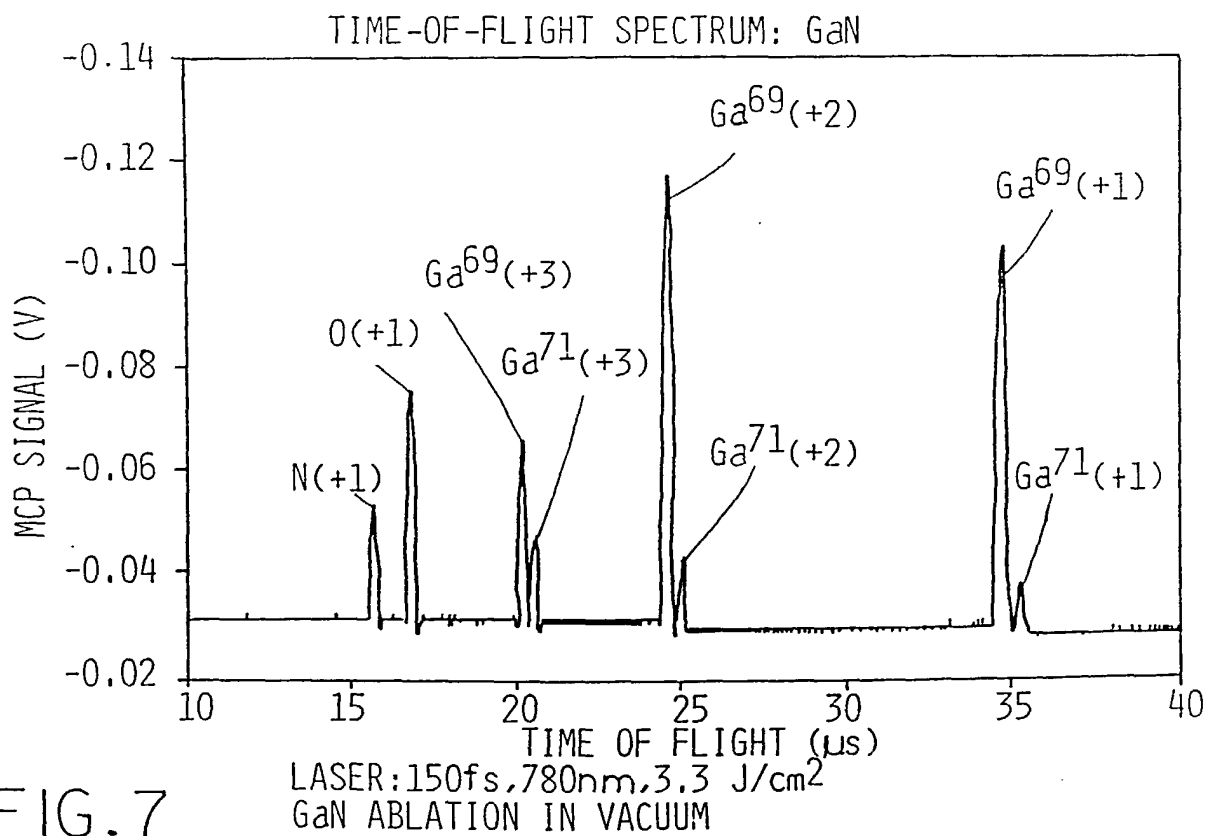


FIG. 7

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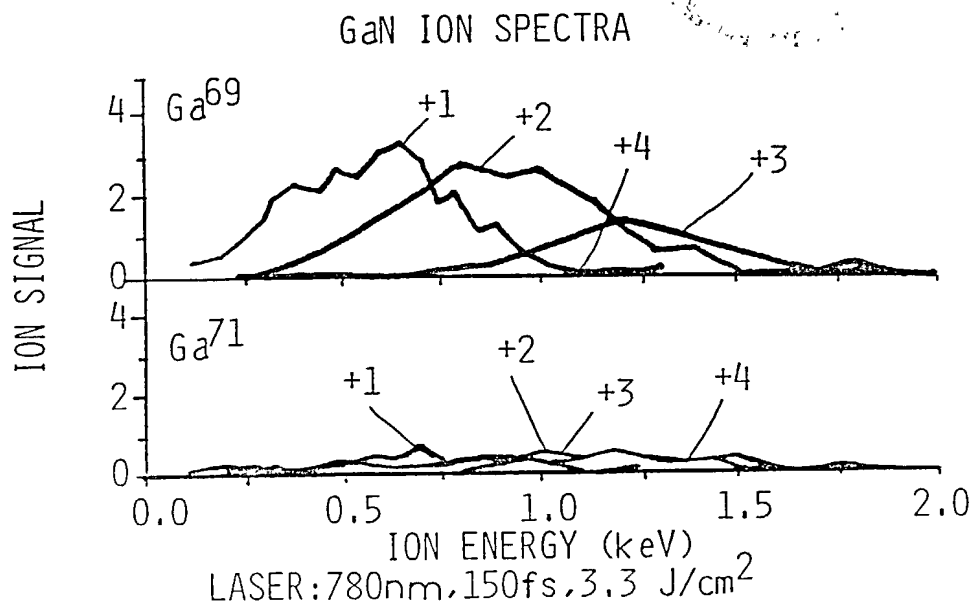


FIG. 8A

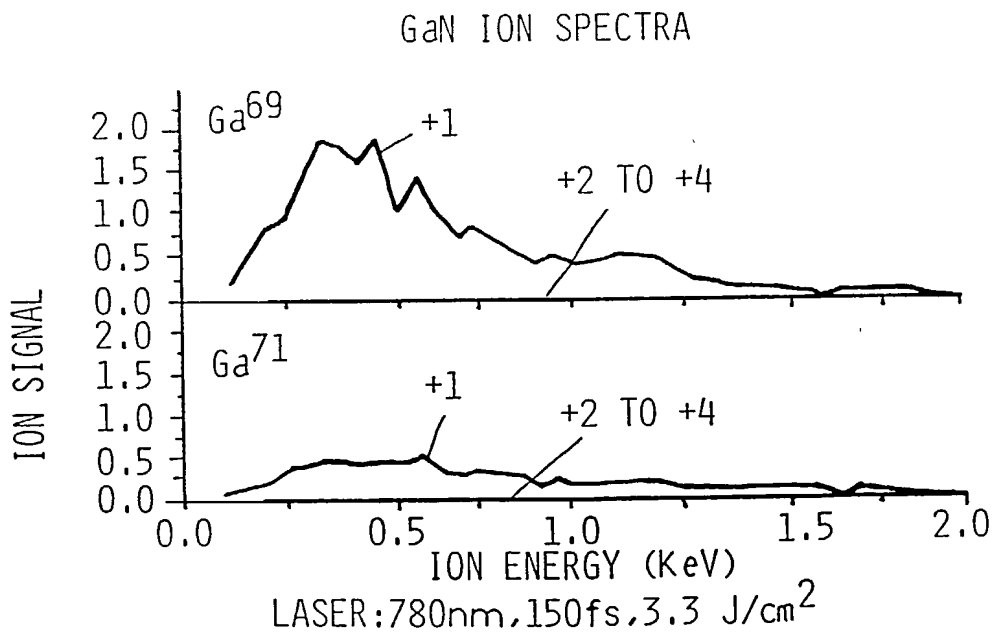
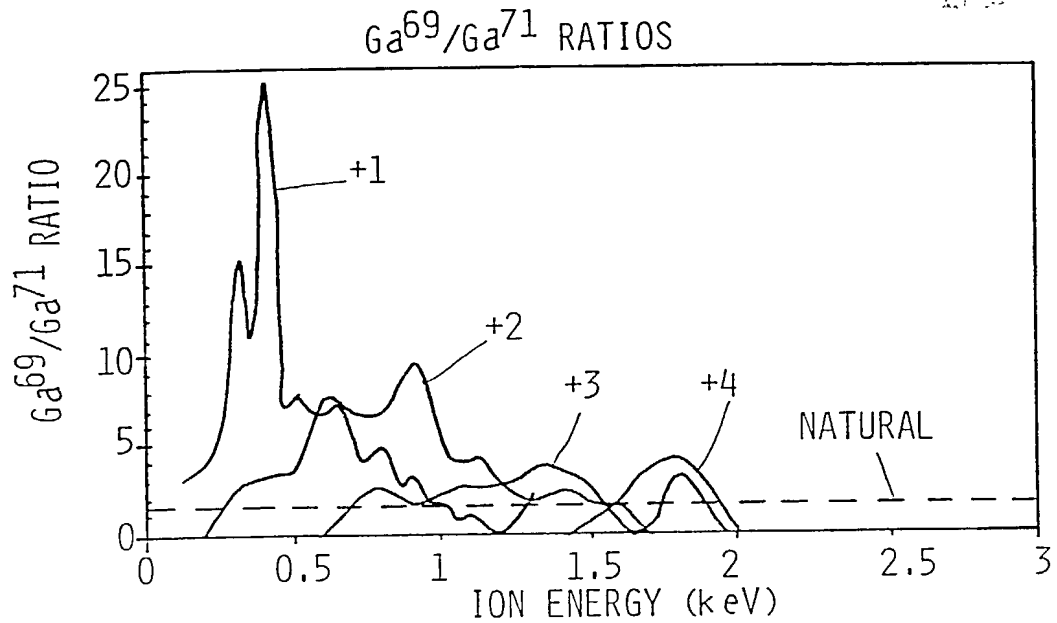


FIG. 8B

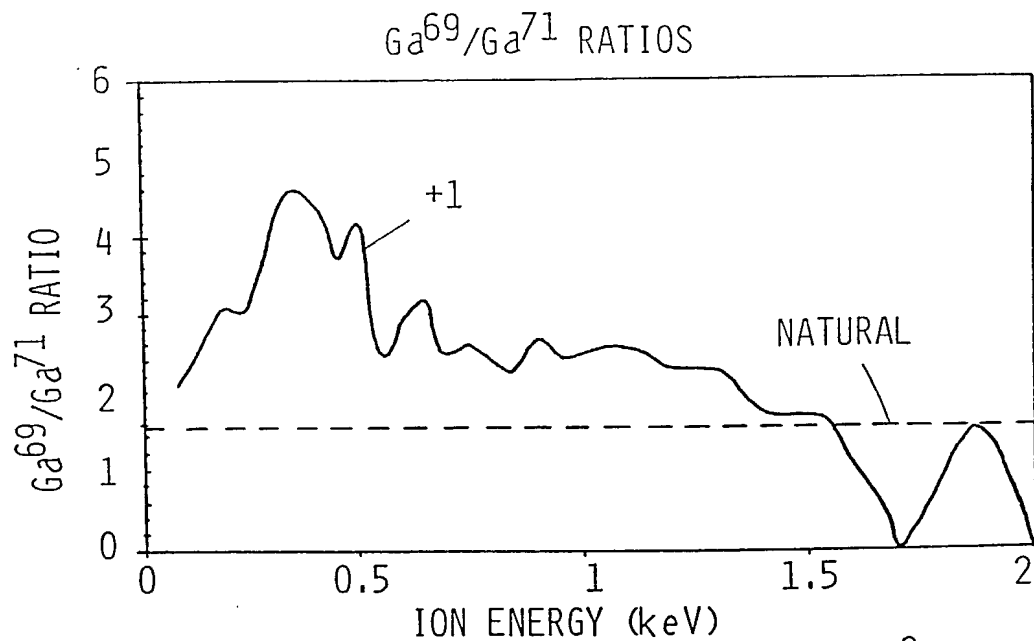


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Ti:SAPPHIRE LASER: 150fs, 3.3 J/cm<sup>2</sup>  
NATURAL:  $\text{Ga}^{69}/\text{Ga}^{71} = 60.4\%/39.6\% = 1.53$

FIG.9A



Ti:SAPPHIRE LASER: 150fs, 3.3 J/cm<sup>2</sup>  
NATURAL:  $\text{Ga}^{69}/\text{Ga}^{71} = 60.4\%/39.6\% = 1.53$

FIG.9B

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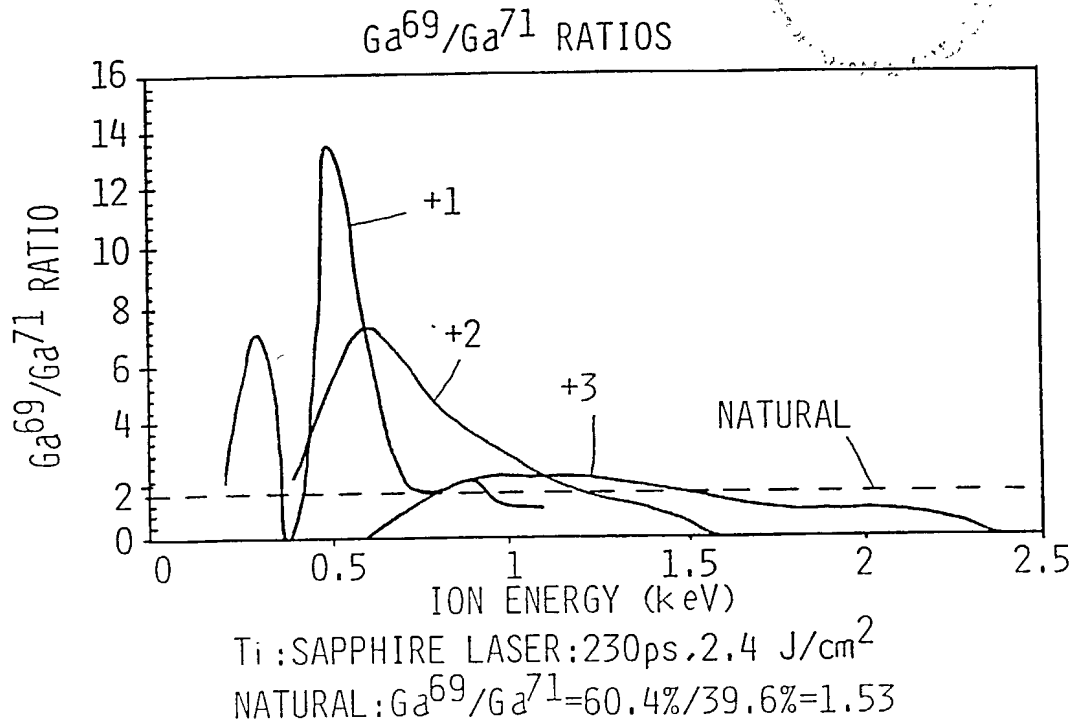


FIG.9C

2" SUBSTRATE HOLDER:  
 TEMPERATURE: -196°C TO 1000°C  
 ROTATION & TRANSLATION  
 MOVED UP AND OUT OF PLUME FOR  
 ELECTROSTATIC ANALYZER

MULTI-TARGET  
 SELECTOR  
 (4 TARGETS WITH  
 ROTATION)

VACUUM: 10<sup>-9</sup> TORR  
 N<sub>2</sub> BACKFILL: 10<sup>-4</sup> TORR

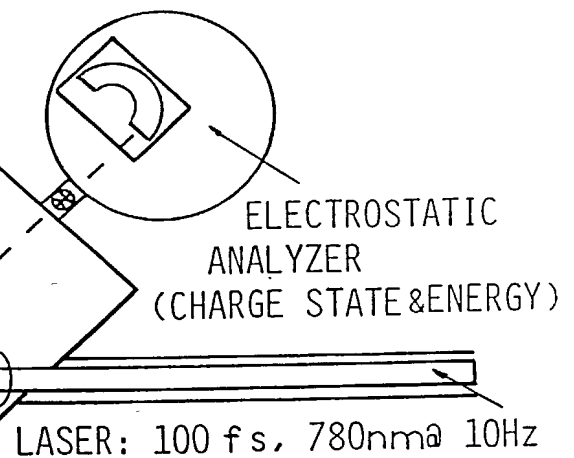


FIG.10

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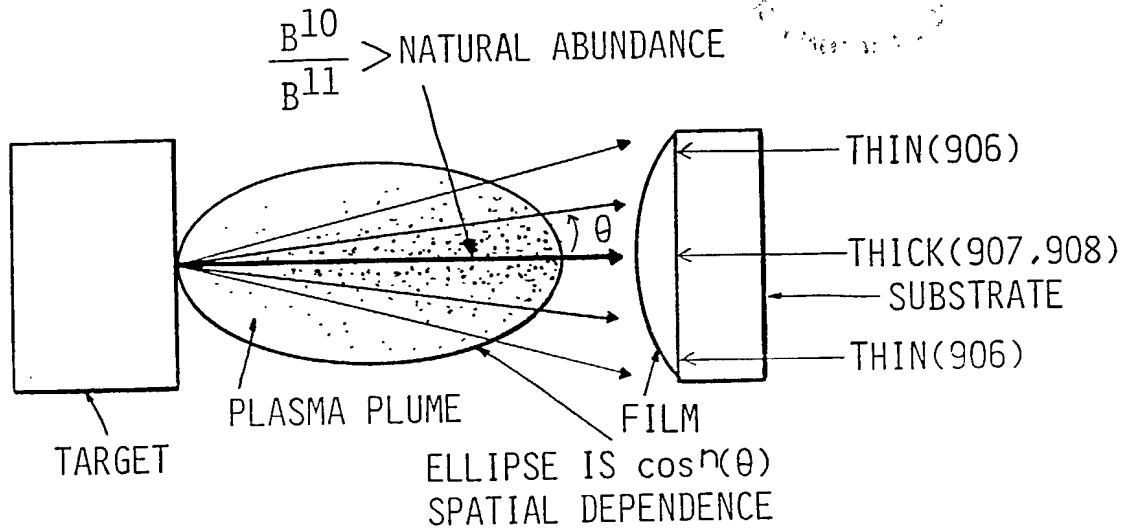


FIG. 11

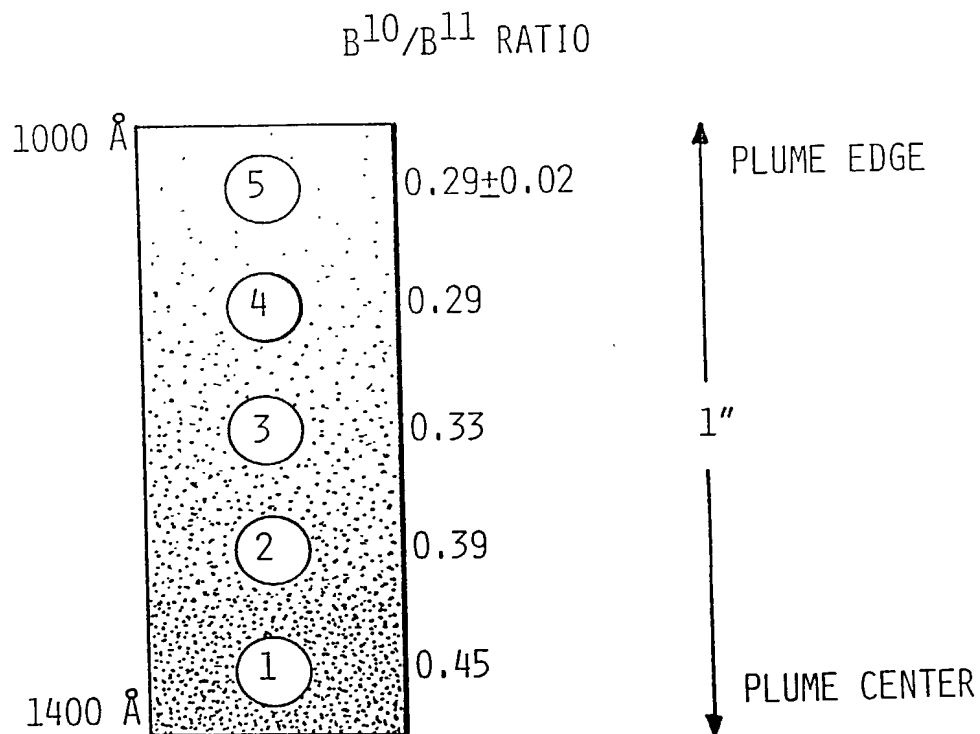
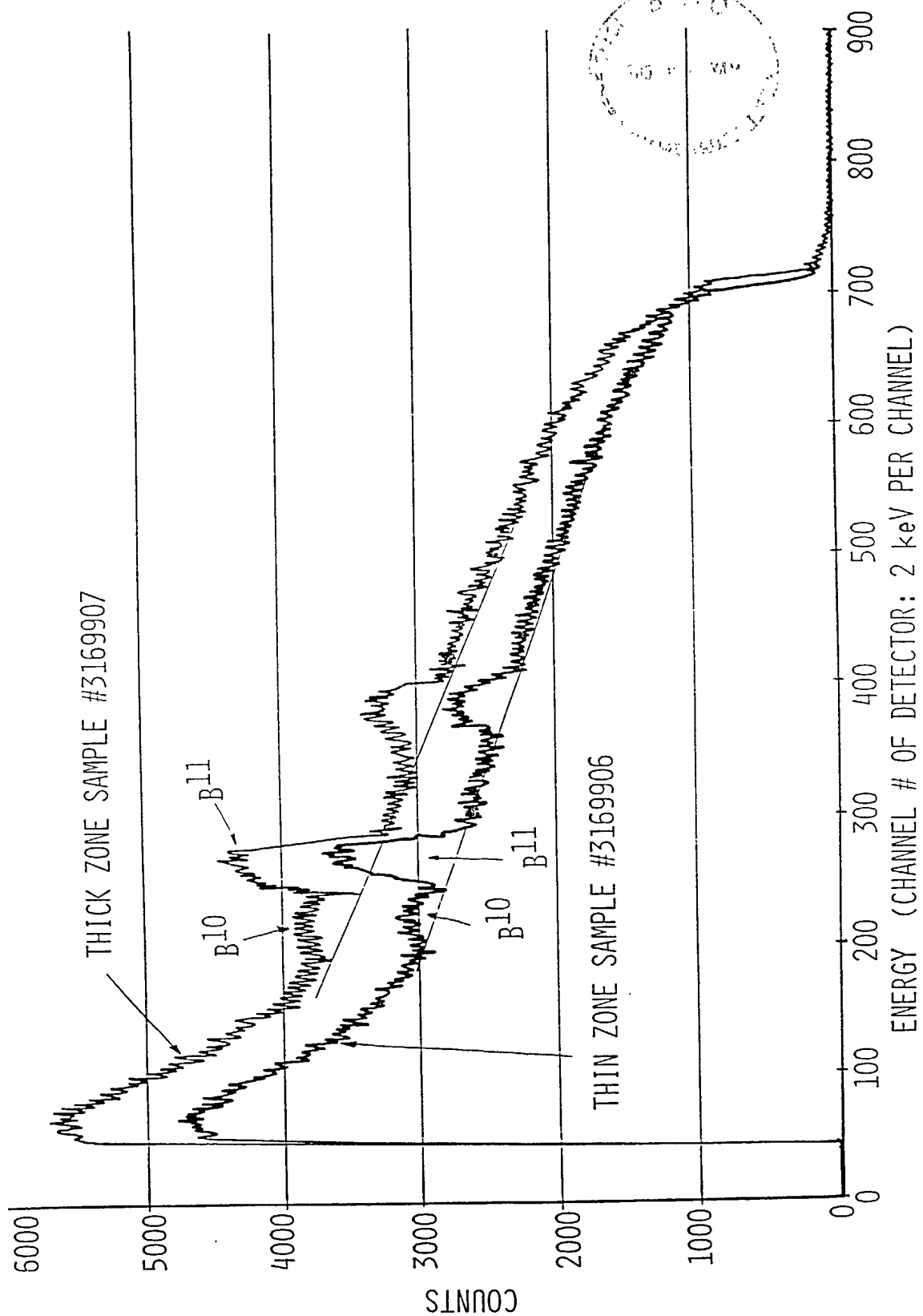


FIG. 14A

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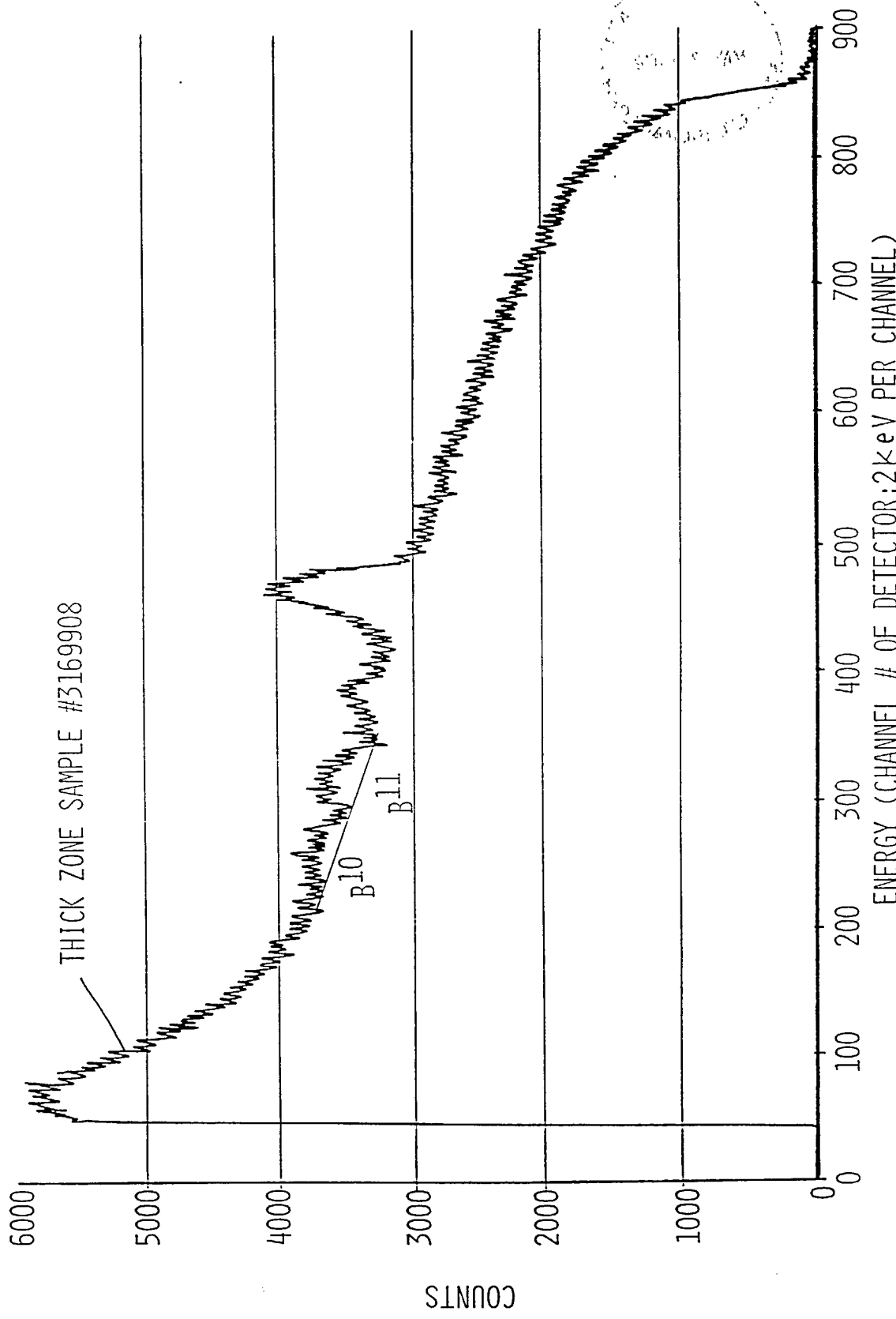


FIG. 13

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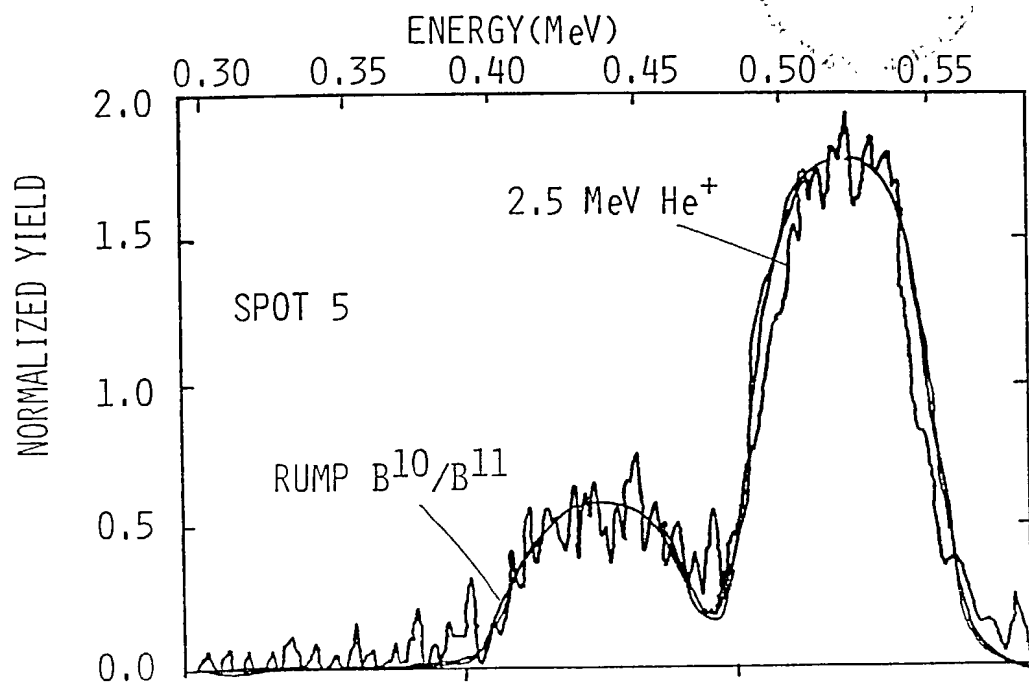


FIG.14B

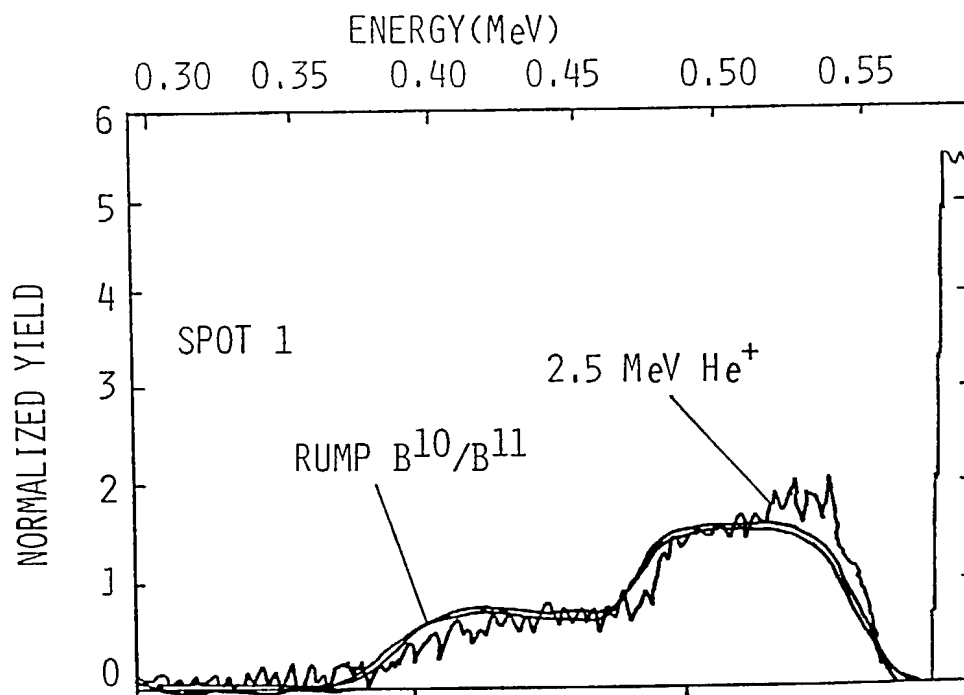


FIG.14C

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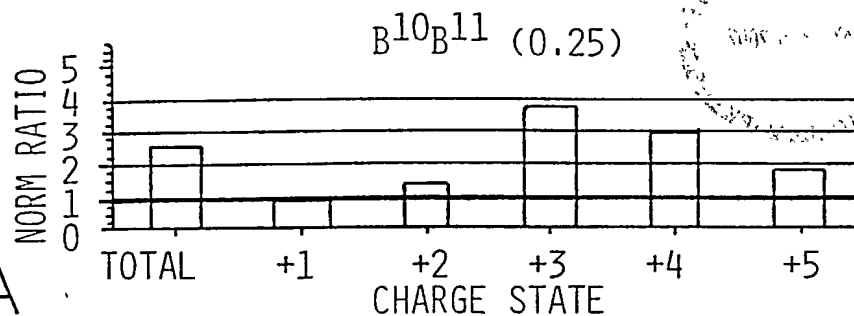


FIG. 15A

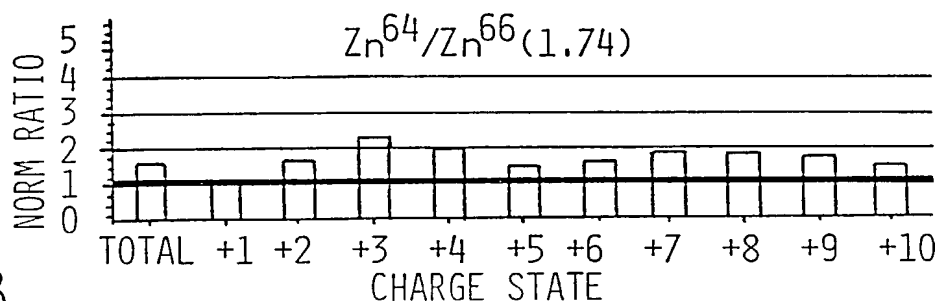


FIG. 15B

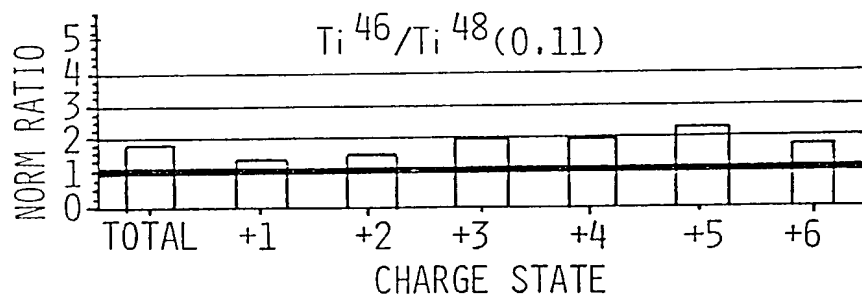


FIG. 15C

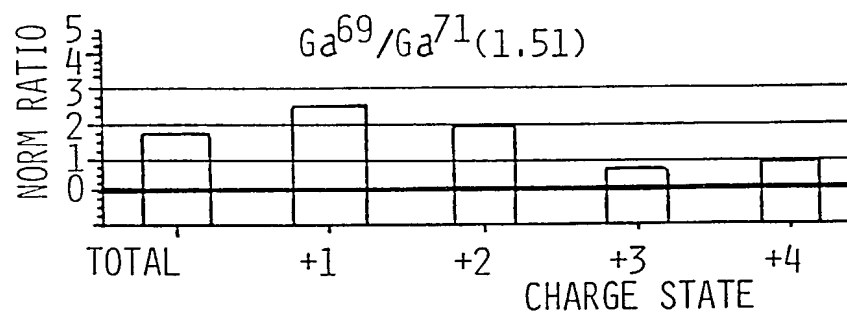


FIG. 15D

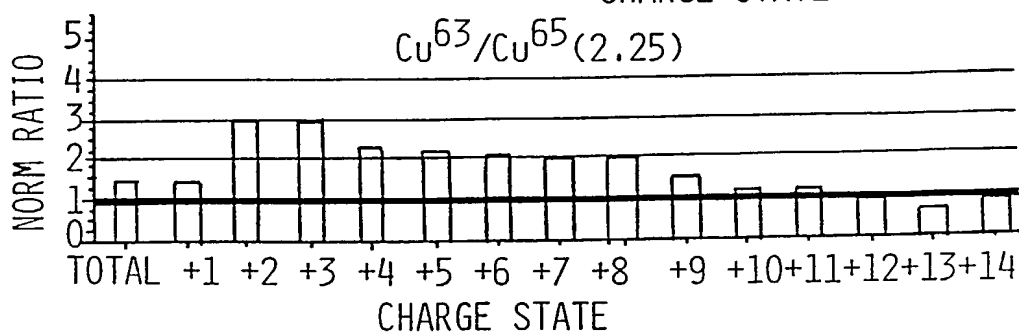


FIG. 15E

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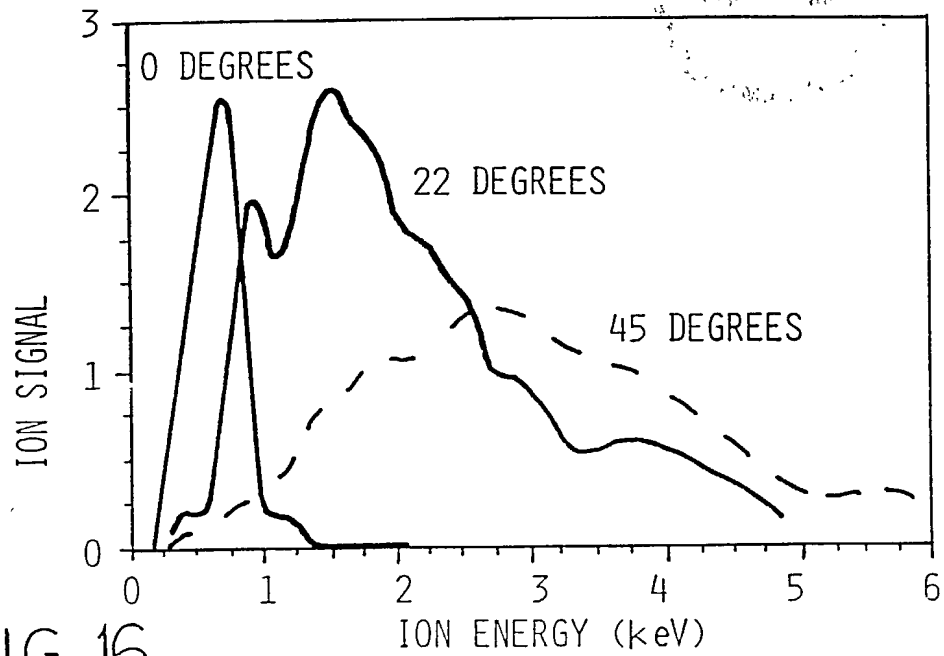


FIG.16

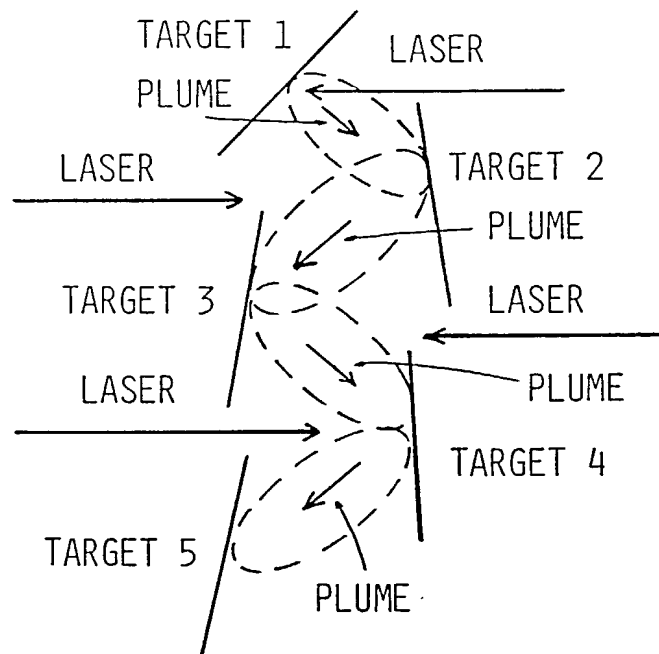


FIG.18



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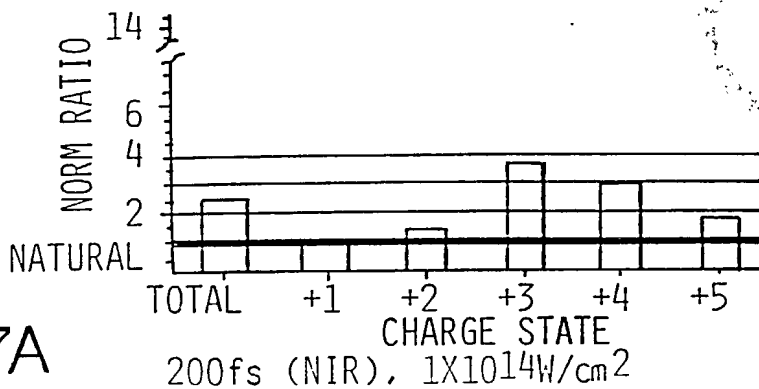


FIG.17A

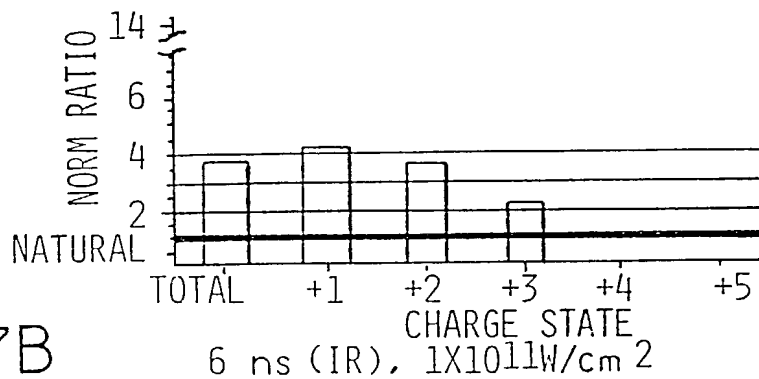


FIG.17B

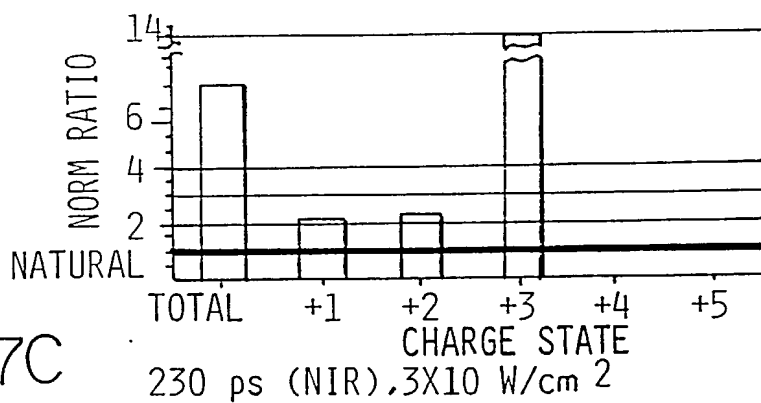


FIG.17C

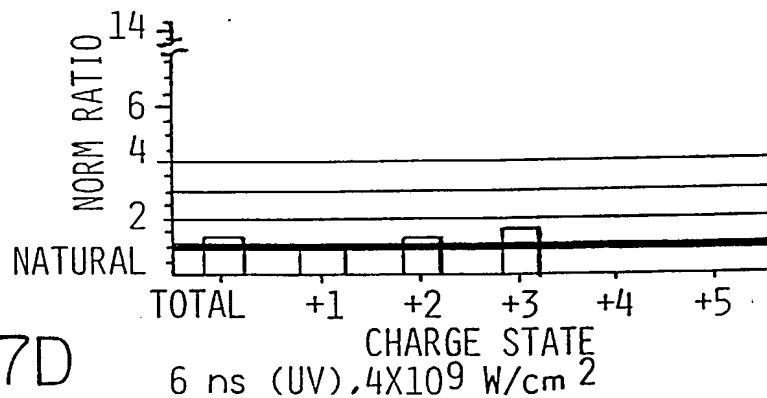


FIG.17D

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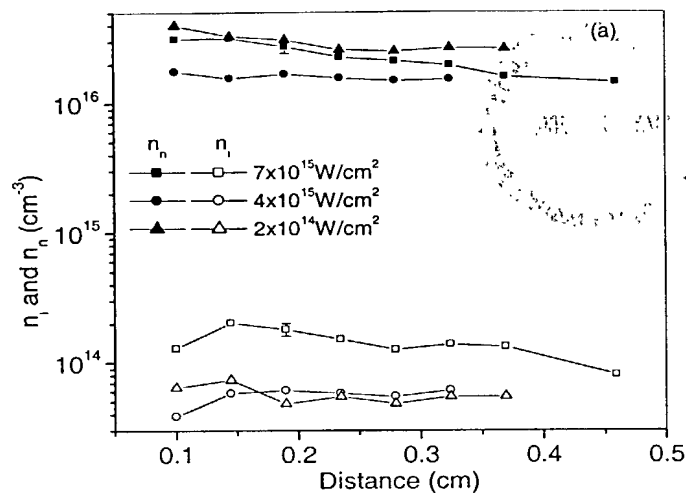


FIG. 19A

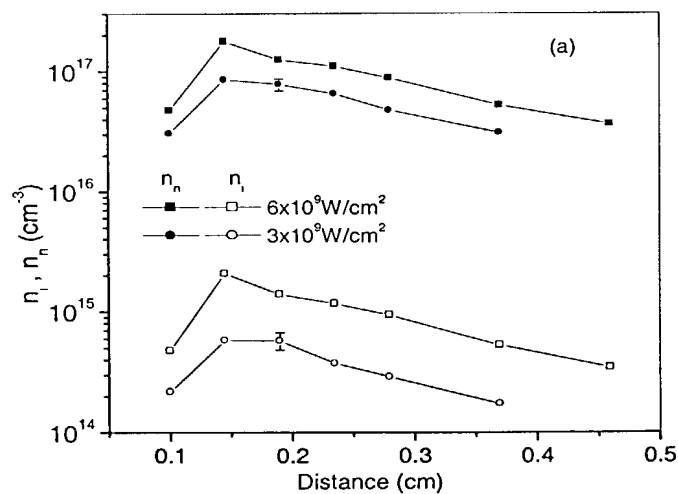


FIG. 19B

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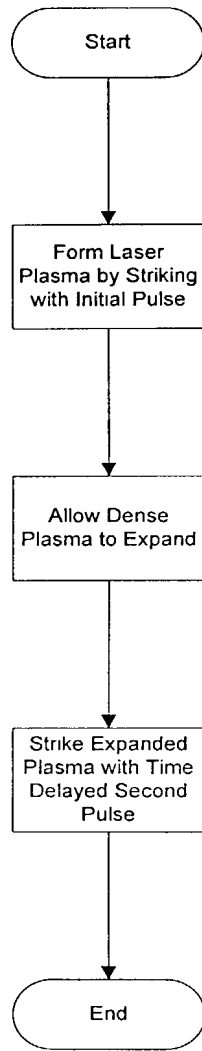


FIG. 20

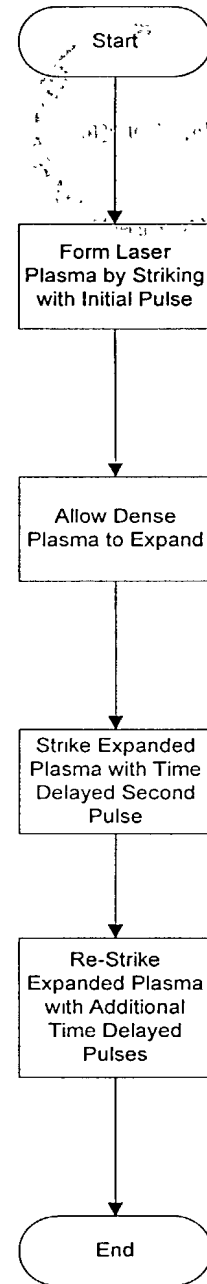
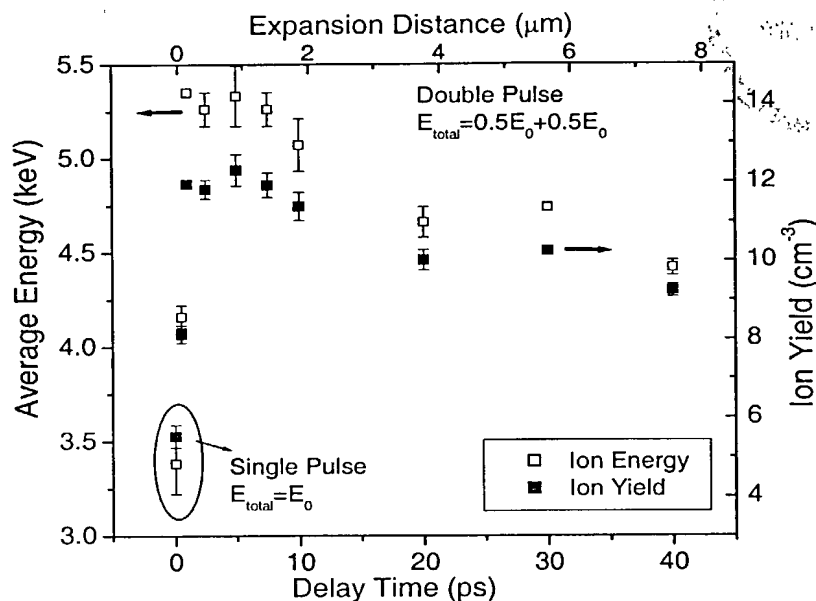


FIG. 23

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FIG. 21



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FIG. 24

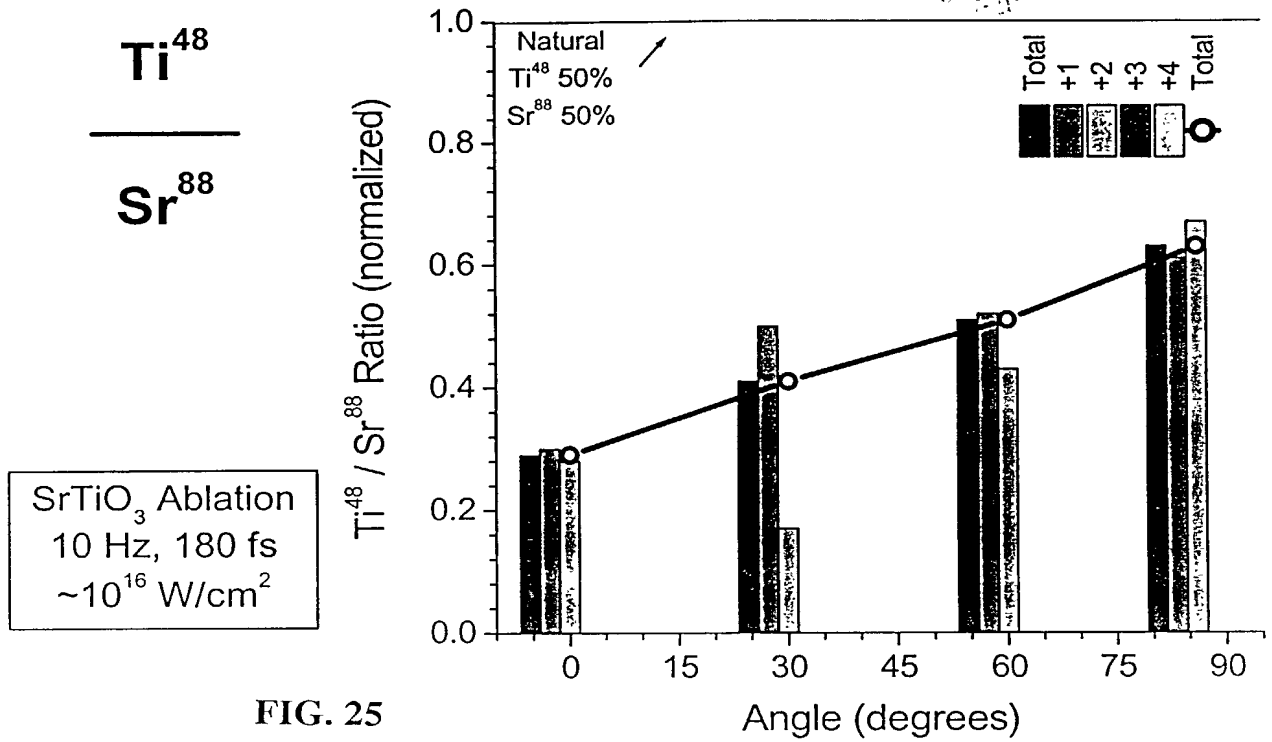
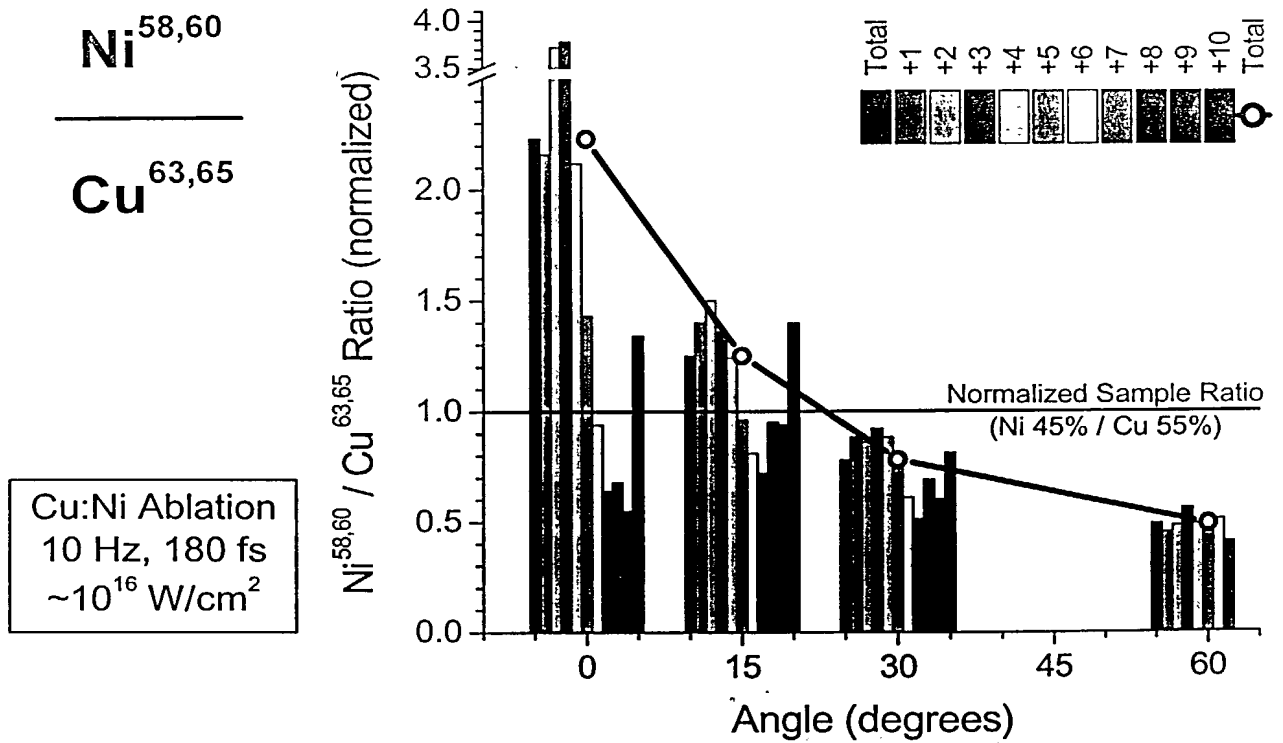


FIG. 25



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FIG. 26

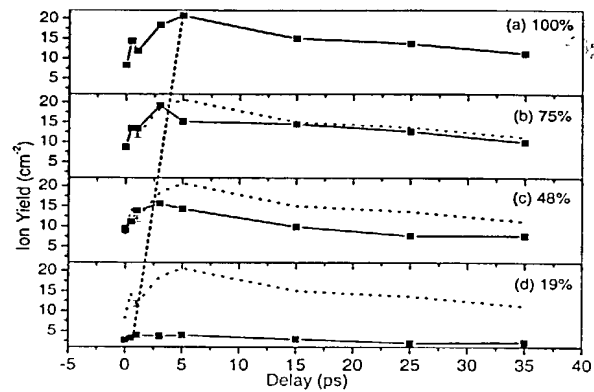


FIG. 27

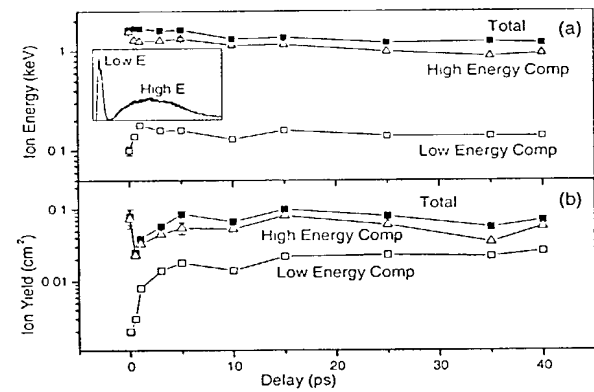
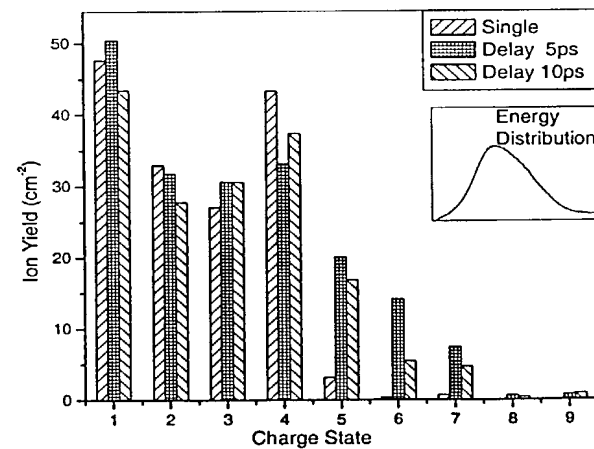


FIG. 28



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FIG. 29

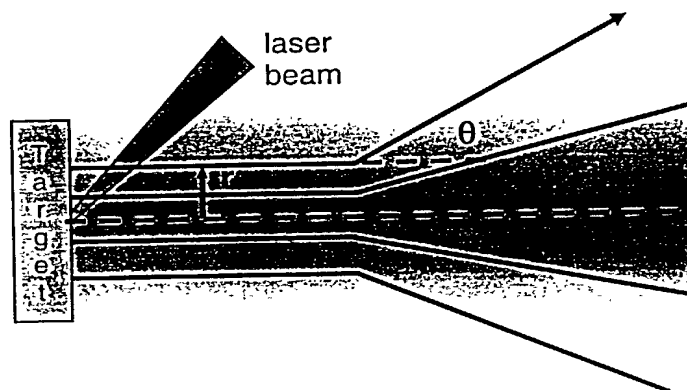
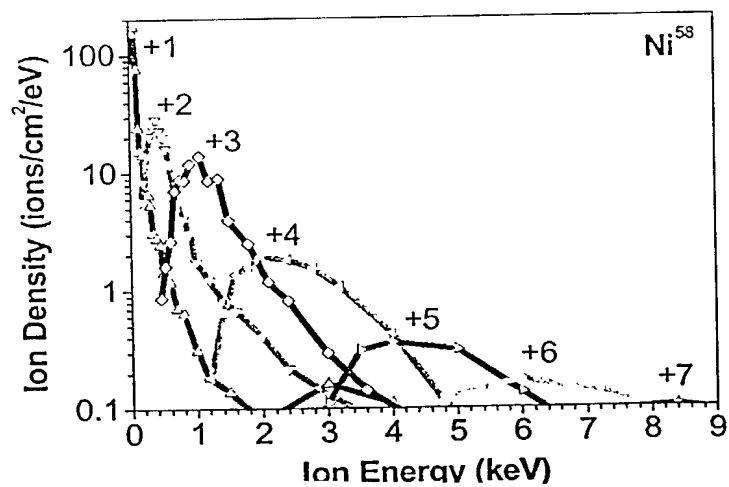


FIG. 30



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FIG. 31

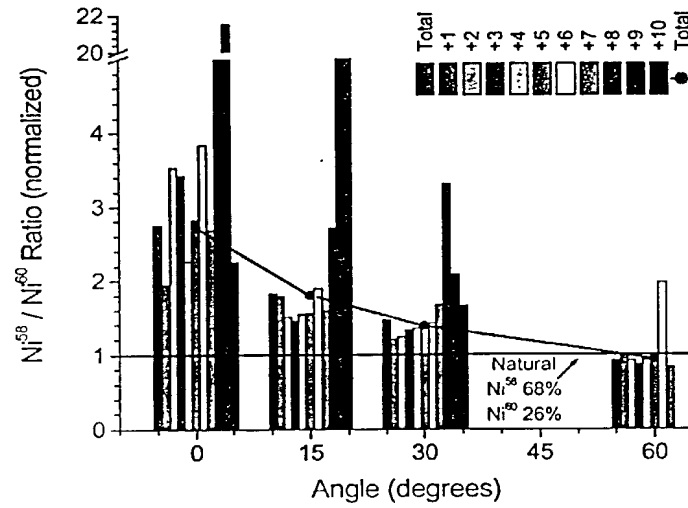


FIG. 32

